

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants :	Yasuhiko KOJIMA, et al.	CONFIRMATION NO. 1461
Serial No.:	10/591,476	Art Unit: 1751
Filed:	September 1, 2006	Examiner: TBA
For:	COPPER FILM DEPOSITION METHOD	

FIFTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449). No copy of the U.S. document cited therein is enclosed.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application, that it be made officially of record therein and that a listing of same appear on the face of any patent which may issue in this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
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March 11, 2009